INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 23, 2026

IGI Report Number	LG847676225
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	8.30 X 5.87 X 3.98 MM

GRADING RESULTS

Carat Weight	1.93 CARAT
Color Grade	D
Clarity Grade	VS 1
Cut Grade	VERY GOOD

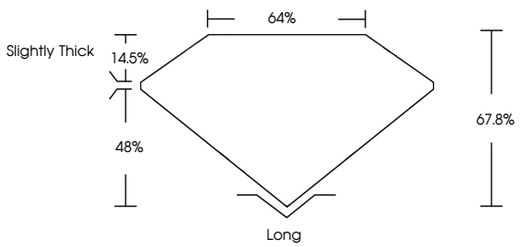
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG847676225

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG847676225
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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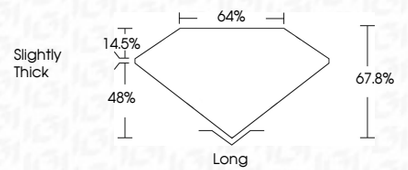
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EMERALD CUT
8.30 X 5.87 X 3.98 MM
Carat Weight 1.93 CARAT
Color Grade D
Clarity Grade VS 1
Cut Grade VERY GOOD
Depth 67.8%
Table 64%
Girdle Slightly Thick
Culet Long
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
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Type IIa